

Day : Saturday
Date: 5/15/2004

Time: 15:06:30

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Inventor Name Search Result

Your Search was:

Last Name = OKUMURA
First Name = TOMOHIRO

Inventor Name Search
09/511,398

Application#	Patent#	Status	Date Filed	Title	Inventor Name 44
10720092	Not Issued	020 28/12	11/25/2003 438/	PLASMA PROCESSING METHOD	OKUMURA, IFW TOMOHIRO
10675922	Not Issued	030 28/12	09/29/2003 438/570	PLASMA DOPING METHOD AND PLASMA DOPING APPARATUS	OKUMURA, IFW TOMOHIRO
10649670	Not Issued	030 17/03	08/28/2003 216/56	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, IFW TOMOHIRO
10647479	Not Issued	030 17/02	08/26/2003 427/569	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, IFW TOMOHIRO
10615851 2004 0045567	Not Issued	030 17/03	07/10/2003 118/723 A	APPARATUS FOR PLASMA DOPING	OKUMURA, IFW TOMOHIRO
10611867 2004 0036038	Not Issued	030 17/03	07/03/2003 118/728	METHOD AND APPARATUS FOR PLASMA DOPING	OKUMURA, IFW TOMOHIRO
10408261 2003 0215578	Not Issued	030 17/02	04/08/2003 427/569	PLASMA PROCESSING METHOD AND APPARATUS AND TRAY FOR PLASMA PROCESSING	OKUMURA, IFW TOMOHIRO Eric Fells
10365449 2004 0075396	Not Issued	020 28/12	02/13/2003 315/1673	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, IFW TOMOHIRO
10357456 2004 0045669	Not Issued	020 28/12	02/04/2003 156/34535	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, IFW TOMOHIRO
10324031	6707253	150	12/20/2002 ?	MATCHING CIRCUIT AND PLASMA PROCESSING APPARATUS	OKUMURA, TOMOHIRO
10207183 2003 00626920	Not Issued	041 17/02	07/30/2002 427/569	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, IFW TOMOHIRO
10197465 2003 0066817	Not Issued	041 17/05	07/18/2002 216/45	DRY ETCHING METHOD AND APPARATUS	OKUMURA, IFW TOMOHIRO
10179857 2002 0168914	Not Issued	041 17/03	06/26/2002 156/345	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, IFW TOMOHIRO
10114238 2002 0153349	Not Issued	041 17/05	04/03/2002 216/186	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, IFW TOMOHIRO

10081587	6630792	150	02/21/2002	HIGH FREQUENCY POWER SOURCE, PLASMA PROCESSING APPARATUS, INSPECTION METHOD FOR PLASMA PROCESSING APPARATUS, AND PLASMA PROCESSING METHOD	OKUMURA, TOMOHIRO
10060350 2002007405	Not Issued	041 1763	02/01/2002 154/34548	METHOD AND APPARATUS FOR PLASMA PROCESSING	OKUMURA, TOMOHIRO IFW
09968810 2002003874	Not Issued	071 1763	10/03/2001 154/345	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, TOMOHIRO IFW
09918823	Not Issued	041 2821	08/01/2001 315/169.4	PLASMA PROCESSING METHOD AND APPARATUS THEREOF	OKUMURA, TOMOHIRO IFW
09903069	6517670	150	07/11/2001 ?	ETCHING AND CLEANING APPARATUS	OKUMURA, TOMOHIRO
09789799	6432730	150	02/22/2001	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, TOMOHIRO
09631671	6346915	150	08/03/2000	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, TOMOHIRO
09589204	Not Issued	161 nd	06/08/2000	METHOD AND APPARATUS FOR PLASMA PROCESSING	OKUMURA, TOMOHIRO
09569056	6355573	150	05/10/2000	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, TOMOHIRO
09511398 (no parent or child listed)	Not Issued	071	02/23/2000	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, TOMOHIRO
09495293	6342139	150	02/01/2000	SPUTTERING SYSTEM	OKUMURA, TOMOHIRO
09339621	6297165	150	06/24/1999 ?	ETCHING AND CLEANING METHODS	OKUMURA, TOMOHIRO
09339620	Not Issued	083 1763	06/24/1999 154/345	INDUCTIVELY COUPLED DRY ETCHING APPARATUS	OKUMURA, TOMOHIRO IFW
09339241	6291937	150	06/24/1999 ?	HIGH FREQUENCY COUPLER, AND PLASMA PROCESSING APPARATUS AND METHOD	OKUMURA, TOMOHIRO
09277729	Not Issued	161 nd	03/29/1999	THIN FILM FORMING METHOD AND APPARATUS	OKUMURA, TOMOHIRO
09180974	6177646	150	11/17/1998	METHOD AND DEVICE FOR PLASMA TREATMENT	OKUMURA, TOMOHIRO
09048254	6093457	150	03/26/1998	METHOD FOR PLASMA PROCESSING	OKUMURA, TOMOHIRO
08996705	6030667	150	12/24/1997	APPARATUS AND METHOD FOR APPLYING RF POWER	OKUMURA, TOMOHIRO

				APPARATUS AND METHOD FOR GENERATING PLASMA AND APPARATUS AND METHOD FOR PROCESSING WITH PLASMA	
08807853	Not Issued	161 <i>akd</i>	02/26/1997	APPARATUS AND METHOD FOR APPLYING RF POWER, APPARATUS AND METHOD FOR GENERATING PLASMA, AND APPARATUS AND METHOD FOR PROCESSING WITH PLASMA	OKUMURA, TOMOHIRO
08749847	5922223	150	11/15/1996	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, TOMOHIRO
08656851	5888413	150	05/30/1996	PLASMA PROCESSING METHOD AND APPARATUS	OKUMURA, TOMOHIRO
08651606	5711850	150	05/22/1996	PLASMA PROCESSING APPARATUS	OKUMURA, TOMOHIRO
08528164	5558722	150	09/14/1995	PLASMA PROCESSING APPARATUS	OKUMURA, TOMOHIRO
08518307	5916820	150	08/23/1995 7	THIN FILM FORMING METHOD AND APPARATUS	OKUMURA, TOMOHIRO
08447936	5693236	150	05/23/1995	WATER-REPELLENT SURFACE STRUCTURE AND ITS FABRICATION METHOD	OKUMURA, TOMOHIRO
08447525	Not Issued	161 <i>akd</i>	05/23/1995	METHOD AND APPARATUS FOR PROCESSING WITH HELICON WAVE PLASMA	OKUMURA, TOMOHIRO
08389229	5609690	150	02/15/1995	VACUUM PLASMA PROCESSING APPARATUS AND METHOD	OKUMURA, TOMOHIRO
08054137	5372648	150	04/30/1993	PLASMA CVD SYSTEM	OKUMURA, TOMOHIRO
07912817	Not Issued	161 <i>akd</i>	07/13/1992	PLUG FOR MOLTEN METAL REFINING VESSEL	OKUMURA, TOMOHIRO
07910626	5265850	150	07/08/1992	REFRACTORY FOR GAS BLOWING FOR MOLTEN METAL REFINING VESSEL	OKUMURA, TOMOHIRO

Inventor Search Completed: No Records to Display.

Search Another: Inventor

Last Name	First Name	
okumura	tomohiro	Search

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Time: 15:23:51

Inventor Name Search Result

Your Search was:

Last Name = HARAGUCHI

First Name = HIDEO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 19
10685459	Not Issued	020 1703	10/16/2003 118/—	PLASMA PROCESSING APPARATUS	HARAGUCHI, HIDEO <i>FFW</i>
09768065	6642533	150	01/24/2001	SUBSTRATE DETECTING METHOD AND DEVICE	HARAGUCHI, HIDEO
09511787	6648976	150	02/23/2000	APPARATUS AND METHOD FOR PLASMA PROCESSING	HARAGUCHI, HIDEO
09511398	Not Issued	071	02/23/2000	PLASMA PROCESSING METHOD AND APPARATUS	HARAGUCHI, HIDEO
09443145	6447613	150	11/19/1999	SUBSTRATE DECHUCKING DEVICE AND SUBSTRATE DECHUCKING METHOD	HARAGUCHI, HIDEO
09315463	6254683	150	05/20/1999	SUBSTRATE TEMPERATURE CONTROL METHOD AND DEVICE	HARAGUCHI, HIDEO
09291657	6276892	150	03/23/1999	WAFER HANDLING APPARATUS	HARAGUCHI, HIDEO
09291148	6340281	150	04/15/1999	METHOD AND APPARATUS FOR POSITIONING A DISK-SHAPED OBJECT	HARAGUCHI, HIDEO
09266656	6255223	150	03/11/1999	SUBSTRATE HANDLING METHOD AND APPARATUS, AND ATTRACTIVE FORCE INSPECTION METHOD AND APPARATUS USED THEREWITH	HARAGUCHI, HIDEO
09180974	6177646	150	11/17/1998	METHOD AND DEVICE FOR PLASMA TREATMENT	HARAGUCHI, HIDEO
08946966	Not Issued	161	10/08/1997	VIDEO CAMERA WITH DUAL RECORDING MEDIUMS FOR CONTINUOUS RECORDING	HARAGUCHI, HIDEO
08932074	5974217	150	09/17/1997	AN INFORMATION TRANSMISSION SYSTEM HAVING A REDUCED NUMBER	HARAGUCHI, HIDEO

				OF STORED PROGRAMS AND RECORDING MEDIA PLAYBACK DRIVES	
<u>08814018</u>	<u>5851296</u>	150	03/10/1997	VACUUM PROCESSING APPARATUS AND METHOD	HARAGUCHI, HIDEO
<u>08774899</u>	<u>5721803</u>	150	12/27/1996	A VIDEO ON DEMAND SYSTEM WHICH DUBS VIDEO PROGRAMS WHEN THERE IS NO IDLE PLAYBACK MEANS	HARAGUCHI, HIDEO
<u>08749847</u>	<u>5922223</u>	150	11/15/1996	PLASMA PROCESSING METHOD AND APPARATUS	HARAGUCHI, HIDEO
<u>08740192</u>	Not Issued	161	10/24/1996	DATA TRANSMITTING/RECEIVING DEVICE, DATA TRANSMISSION DEVICE AND DATA RECORDING/PLAYBACK DEVICE AND METHODS THEREOF	HARAGUCHI, HIDEO
<u>08380713</u>	<u>5636963</u>	150	01/30/1995	METHOD OF HANDLING WAFERS IN A VACUUM PROCESSING APPARATUS	HARAGUCHI, HIDEO
<u>08280353</u>	Not Issued	166	07/26/1994	INFORMATION TRANSMISSION SYSTEM	HARAGUCHI, HIDEO
<u>08168230</u>	<u>5450139</u>	250	12/17/1993	APPARATUS FOR TRANSMITTING VIDEO SIGNALS COMPRISING A MEMORY BACKUP DEVICE	HARAGUCHI, HIDEO

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 PALM INTRANET**Inventor Name Search Result**

Your Search was:

Last Name = MATSUI

First Name = TAKUYA

Application#	Patent#	Status	Date Filed	Title	Inventor Name 8
<u>60428600</u>	Not Issued	020	11/22/2002	FUSED BICYCLIC NITROGEN-CONTAINING HETEROCYCLES	MATSUI, TAKUYA
<u>10720844</u>	Not Issued	019	11/21/2003	FUSED BICYCLIC NITROGEN-CONTAINING HETEROCYCLES	MATSUI, TAKUYA
<u>10179857</u>	Not Issued	041	06/26/2002	PLASMA PROCESSING METHOD AND APPARATUS	MATSUI, TAKUYA
<u>09789799</u>	<u>6432730</u>	150	02/22/2001	PLASMA PROCESSING METHOD AND APPARATUS	MATSUI, TAKUYA
<u>09631671</u>	<u>6346915</u>	150	08/03/2000	PLASMA PROCESSING METHOD AND APPARATUS	MATSUI, TAKUYA
<u>09569056</u>	<u>6355573</u>	150	05/10/2000	PLASMA PROCESSING METHOD AND APPARATUS	MATSUI, TAKUYA
<u>09511787</u>	<u>6648976</u>	150	02/23/2000	APPARATUS AND METHOD FOR PLASMA PROCESSING	MATSUI, TAKUYA
<u>09511398</u>	Not Issued	071	02/23/2000	PLASMA PROCESSING METHOD AND APPARATUS	MATSUI, TAKUYA

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	<input type="text" value="matsui"/>	<input type="text" value="takuya"/>	

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 **PALM INTRANET**

Time: 15:31:03

Inventor Name Search Result

Your Search was:

Last Name = MITSUHASHI

First Name = AKIO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 4
<u>09511398</u>	Not Issued	071	02/23/2000	PLASMA PROCESSING METHOD AND APPARATUS	MITSUHASHI, AKIO
<u>09339620</u>	Not Issued	083	06/24/1999	INDUCTIVELY COUPLED DRY ETCHING APPARATUS	MITSUHASHI, AKIO
<u>07771516</u>	5127306	150	10/02/1991	APPARATUS FOR APPLYING PANNING EFFECTS TO MUSICAL TONE SIGNALS AND FOR PERIODICALLY MOVING A LOCATION OF SOUND IMAGE	MITSUHASHI, AKIO
<u>07464964</u>	Not Issued	166	01/16/1990	APPARATUS FOR APPLYING PANNING EFFECTS TO MUSICAL TONE SIGNALS AND FOR PERIODICALLY MOVING A LOCATION OF SOUND IMAGE	MITSUHASHI, AKIO

Inventor Search Completed: No Records to Display.

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<input type="text" value="mitsuhashi"/>	<input type="text" value="akio"/>
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1	L1	40	(("6707253") or ("6630792") or ("6517670") or ("6432730") or ("6346915") or ("6355573") or ("6297165") or ("6291937") or ("6177646") or ("6093457") or ("6030667") or ("5922223") or ("5888413") or ("5711850") or ("5558722") or ("5916820") or ("5609690") or ("5372648") or ("6648976") or ("5851296")) .PN.	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/05/15 16:42
2	L2	1236 3	((427/488-491,534 -539,569-597) or (216/66,71,69) or (118/723I,723AN)) .CCLS.	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/05/15 16:44
3	L3	0	("2and(antennacoi l)") .PN.	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/05/15 16:45
4	L4	2485	2 and (antenna coil)	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/05/15 16:47
5	L5	117	plasma adj trap	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/05/15 16:46
6	L6	6	4 and 5	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/05/15 16:48

EAST search -

	L #	Hits	Search Text	DBs	Time Stamp
7	L7	44	5 and (antenna coil) not 6	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/05/15 16:47
8	L8	191	4 and trap not 6	USPAT; US-PGPUB ; EPO; JPO; DERWENT; IBM_TDB	2004/05/15 16:48